

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED  
DEPOSITION (IBAD)

App. No.: 10/602,467 Filed: June 23, 2003

Examiner: Brian K. Talbot Group Art Unit: 1762

Customer No.: 34456 Confirmation No.: 2664

Atty. Dkt. No.: 1014-SP103

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MS AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO FINAL OFFICE ACTION**

Dear Sir:

In response to the Final Office Action mailed June 30, 2008, please amend the above-identified application as follows:

The Claim Amendments begin on page 2.

The Remarks being on page 8.